## OPTO $\in N G I N \in \in R I N G$ <br> THE TELECENTRIC COMPANY

## LTPR SERIES

The projection pattern can be easily integrated into the LTPR projection unit by unscrewing the retaining ring that holds the pattern itself. This simple procedure makes it easy to interchange different patterns on the same projection unit. The pattern outer diameter is 21 mm , while the active projection area is a circle of 11 mm : all the significant features of the pattern are drawn inside such a circle. The projection area will show the same aspect ratio as the pattern. The projection accuracy depends both on the pattern manufacturing accuracy and lens distortion. The projection edge sharpness depends on both the lens resolution and the engraving technique: Laser-engraved patterns (part numbers ending in "L") or Photolithography-engraved patterns (part numbers ending in "P") can be chosen depending on the type of application.

## Pattern selection



photolithography patterns laser engraved patterns

| Substrate | soda lime glass | Substrate | borfloat gloss |
| :--- | :--- | :--- | :--- | :--- |
| Coating | Chrome | Coating | dichroic miror |
| Geometrical accuracy | 2 2 micron | Geometrical accuracy | 50 micron |
| Edge Sharpness | 1.4 micron | Edge Sharpness | 50 micron |



P/N: PT00000300P stripe pattern


P/N: PT00000500P edge pattern

P/N: PT00000100L line pattern


P/N: PT00000300L stripe pottern


P/N: PT00000400L grid pottern


P/N: PT00000500L


## CUSTOM-MADE PATTERN

Custom-made patterns suitable for specific needs can be supplied on request.
A drawing with all the significant geometrical information must be submitted (please refer to the instructions here below).

fill-in the
opaque features
keep white the light-trasmitting features

## LTPR SERIES

## Projection lens selection



The pattern drawing that has to be projected must be inscribed in a circle whose diameter is 11 mm , same diagonal of a $2 / 3^{\prime \prime}$ detector.
For example, the pattern drawing could cover the entire 11 mm diameter area or be like a $8.8 \times 6.6 \mathrm{~mm}$ rectangle (same size of a $2 / 3^{\prime \prime}$ detector) or, again, be a square whose side is 7.78 mm .
Unless the projection optics introduces significant distortion, the shape of the projection respects the same features and aspect ratio of the engraved area of the pattern. The projected area dimensions will be " $M$ " times the original dimensions of the pattern, where $M$ is the optical magnification at which the selected projection lens is operating.
LTPR units can integrate most types of high resolution lenses. Besides our OEPL optics, specifically tailored for this projection application, any high resolution C-mount lens can be used, provided it is tailored for $2 / 3^{\prime \prime}$ detectors ( 11 mm image diagonal). Telecentric lenses for $2 / 3^{\prime \prime}$ detector can also be interfaced, thus providing a parallel projection of the pattern scheme and enabling unparalleled performances in 3D measurement applications. C-mount lenses and telecentric optics can be connected to the unit by means of the mount adaptor included in the product package. Here below are listed the projection diameters and the recommended projection distances achievable by means of different types of optics.

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[^0]:    ${ }^{*}$ ) $=$ spacers maybe needed to compensate back focal length

